

## SEARCH

Class	Sub.	Date	Exmr.
219	390 405 411 121.6- 121.66 121.74- 121.78 121.82	11/16/04	868
118	724 725 SD-1		
392	416 418		
updated 5/1/05, 868			

## INTERFERENCE SEARCHED

Class	Sub.	Date	Exmr.
219	8405	9/6/05	868
118	AS		
392	AD-10		

## SEARCH NOTES

(List databases searched. Attach search strategy inside.)

	Date	Exmr.
ENST	11/16/04	868
pol 4v1253, Dreuxster, angle, laser diode silicon substrate wafer polysilicon dioxide coat, layer	5/11/05	868

Best Available Copy